



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re a	pplication of:	) Docket No. LAM2P298
Linda BRALY et al.		)
		) Examiner: W. Powell
Application No. 10/002,676		)
	-	) Group Art Unit: 1765
Filed:	October 31, 2001	)
	•	) Date: January 8, 2004
For:	METHOD FOR PLANARIZATION	j
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	BY INTERFEROMETRY PRIOR TO	ý
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**CERTIFICATE OF MAILING** 

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on January 8, 2004.

Diane Schwanbeck

AMENDMENT UNDER 37 C.F.R. § 1.312

**Commissioner for Patents** P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 C.F.R. § 1.312, please amend this application as follows:

The Amendments to the Claims made herein are reflected in the Listing of Claims, which begins on page 2 of this paper.

Applicants' Remarks begin on page 9 of this paper.